

2132 1FW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	Provident Project P. I		
HIROSHI KOGA Application No.: 09/987,833		Examiner: Benjamin E. Lanie		
		Group Art Unit: 2132		
Filed: November 16, 2001	;)			
For: AUTOMATIC AUTHENTICATION METHOD AND SYSTEM IN PRINT PROCESS	; ; ;	January 30, 2006 (Monday)		
Mail Stop Amendment Commissioner for Patents				

INFORMATION DISCLOSURE STATEMENT

Sir:

P.O. Box 1450

Alexandria, VA 22313-1450

Pursuant to 37 C.F.R. § 1.56, Applicant respectfully directs the Examiner's attention to the documents listed below and on the enclosed Form PTO-1449. A copy of each of the listed documents is enclosed.

- (1) JPA 09-048165
- (2) JPA 09-185474
- (3) JPA 2000-035871

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

January 30, 2006 (Monday)
(Date of Deposit)

Edward A. Kmett (Reg. No. 42,746)

(Name of Attorney for Applicant)

January 30, 2006 (Monday)
Signature
Date of Signature

These documents were cited in a Japanese Office Action dated October 28, 2005 in a Japanese application corresponding to the above-identified application. A copy of the Japanese Office Action together with an English-language translation is enclosed herewith.

English-language abstracts for each of the foregoing Japanese documents have been located and are enclosed for the Examiner's consideration. A concise explanation of relevance for each of the non-English language documents is believed to be provided by the English language abstracts. See MPEP § 609.

Inasmuch as this application has received an action on the merits, but has not yet received any of a final action, a notice of allowance or an action that otherwise closes prosecution on the merits, this Information Disclosure Statement is filed under 37 C.F.R. 1.97(c). Accordingly, in view of the date of the Japanese Office Action, Applicant hereby submits that each item of information cited in this IDS was first cited in a communication from a foreign patent office for a corresponding foreign application not more than three months before the filing of this IDS. Therefore, consideration of the art cited herein is deemed proper and it is respectfully requested that the Examiner make an independent determination of the materiality of the information to the claimed invention. Additionally, the Examiner is requested to indicate that the information has been considered by initialing the appropriate portion of the enclosed Form PTO-1449 and to return the initialed form to Applicant with the next communication.

Applicant's undersigned attorney may be reached in our Costa Mesa, California office by telephone at (714) 540-8700. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

Edward A. Kmett Attorney for Applicant Registration No.: 42,746

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza

New York, New York 10112-3800 Facsimile: (212) 218-2200

FORM PTO 1449 (modi	diffied)	FFR 0 2 2000	ATTY DOCKET NO.	APPLICAT	TION NO.	
	DEPARTMENT OF COMME		00862.022437.		09/987,8	133
LIST OF RE	EFERENCES CITED BY APP Ise several sheets if necessar	PLOWIS)	APPLICANT HIROSH	I KOGA		
	e several should	())	FILING DATE November 16, 2001		GROUP 21	132
			U.S. PATENT DOCUMENTS			
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE
			FOREIGN PATENT DOCUMENTS			
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
	09-048165	02/18/1997	JAPAN			Abstract
	09-185474	07/15/1997	JAPAN			Abstract
	2000-035871	02/02/2000	JAPAN			Abstract
	-				1	
		OTHER DOCUMENT(S)	6) (Including Author, Title, Date, Pertinent Pages, Etc.)			
						ļ
EXAMINER			DATE CONSIDERED			

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.